



PATENT APPLICATION

1R RCE \$

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Makoto HIRANO et al.

Group Art Unit: 1792

Application No.: 10/570,156

Examiner: N. FORD

Filed: March 27, 2006

Docket No.: 127194

For: SUBSTRATE TREATMENT EQUIPMENT
AND MANUFACTURING METHOD OF
SUBSTRATE

MAIL STOP RCE

**LARGE ENTITY REQUEST FOR
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

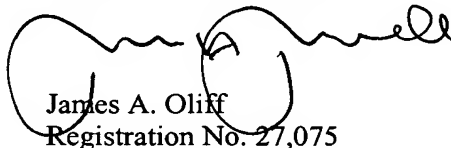
In accordance with the provisions of 37 C.F.R. §1.114, Applicant(s) hereby request(s) continued examination.

☒ Applicant(s) further request(s) entry and consideration of the attached submission.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 216695 in the amount of ☒ \$810.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,


James A. Oliff
Registration No. 27,075

Rodney H. Rothwell, Jr.
Registration No. 60,728

JAO:RHR/nlp

Date: March 27, 2009

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P.O. Box 320850
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DEPOSIT ACCOUNT USE
AUTHORIZATION
Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461

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